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SENSORS AND ACTUATORS B CHEMICAL

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Author Index of Volume B 99

Aboul-Enein, H.Y., 539
Ahn, J.-H., 118
Ahn, J.-P., 18
Aizawa, M., 106
Akhond, M., 410
Alam, M.K., 480
Alieva, E.V., 90
Amao, Y., 130
Ando, M., 613
Aono, H., 113, 141
Arbiol, J., 74, 297
Arndt, K.-F., 451, 579

Backhouse, C.J., 592
Bae, Y.H., 393
Bagheri, M., 608
Barocas, V.H., 25
Basu, B.J., 459
Berdondini, L., 505
Bhat, V.S., 98
Bhattacharjee, G., 36
Bi, S., 468
Bouguettaya, M., 437
Bourillot, E., 58
Brezmes, J., 201, 267
Brinzari, V., 297
Britt, P.F., 223
Bubb, D., 223
Bund, A., 579

Cabot, A., 74, 297
Cao, X., 30
Casans, S., 42
Cerneavschi, A., 297
Chah, S., 216
Chandrasekaran, R., 336
Chen, C., 310
Chen, C.-L., 1
Chen, H.-I., 425
Chen, I.-C., 304
Chen, L., 14
Chen, Q., 511
Chen, Y.-F., 174
Cheng, C.-C., 425
Cheng, J.-Y., 186
Chieng, C.C., 174
Choi, S.-D., 288
Choi, Y.-K., 323
Cornet, A., 297
Correig, X., 201, 267
Cui, X., 437
Cunningham, B.T., 6

Davidson, J.L., 207
de Heer, M.P., 544
de Rooij, N.F., 505
Delinger, W.D., 474
Deng, T., 123
Detwiler, E., 571
Di, J., 468
Dorozhkin, L.M., 568
Du, W., 399, 399, 405, 405
Dufour, B., 601

Eastman, M.P., 474
Egashira, M., 532
Eyraud, V., 58

Fedorov, A.G., 273
Ferrell, T.L., 149
Fienbork, D., 163
Finot, E., 58
Floate, S., 236
Flounders, A.W., 163
Fréchet, J.M.J., 66
Fujiwara, Y., 130

Gerstenmaier, J., 6
Gholam Hosseini, H., 253
Gong, F.-C., 562
Goubard, F., 516
Gu, L., 491
Gualdrón, O., 267
Guan, Y., 14
Gunter, R.L., 474
Guo, L., 310, 499
Gurbuz, Y., 207
Guth, U., 258, 373

Hahn, C.E.W., 236
Han, G., 525
Hancock, J.M., 437
Hartshorne, H., 592
Haruta, M., 613
Hasegawa, Y., 361
Hawk, J.E., 223
Hayashi, K., 315
He, J.-B., 1
Hedden, D.L., 223
Heintz, O., 58
Hetznecker, A., 373
Higginson, N.A.C., 134
Ho, C.E., 174
Holloway, A.F., 355
Houser, E.J., 223
Howitz, S., 451
Hsiao, R.-H., 281
Hsu, K.-H., 186
Hu, S.-Q., 123
Hu, X., 310
Huang, H.M., 174
Huang, Q.-A., 491
Huang, X., 330, 444
Hubalek, J., 201
Huh, M.-Y., 18

Iijima, S., 613
Ijeri, V.S., 98
Itagaki, Y., 113
Ito, J., 431
Ivanov, M., 297
Ivanov, P., 201
Izumi, R., 315

Jang, Y.-T., 118
Janssen, G.J.M., 544
Jeon, S., 323
Jiménez-Pérez, J.L., 149
Ju, B.-K., 118
Ju, Y.H., 344

Kamei, K.-i., 106
Kaneko, T., 156
Kaneto, K., 601
Kang, W.P., 207
Katsube, T., 361
Keller, M., 579
Kerns, D.V., 207
Kido, A., 532
Kim, B.-G., 623
Kim, J.-H., 18
Kim, Y.-K., 623
Kobatake, E., 106
Kobayashi, T., 613
Kohler, H., 373
Kojima, K., 156
Konopsky, V.N., 90
Kooser, A., 474
Korotcenkov, G., 297
Koudelka-Hep, M., 505
Kuckling, D., 451
Kumar, A., 340

Lee, C.-S., 623
Lee, H.K., 323
Lee, L.P., 615
Lee, S.-H., 623
Lee, W.E., 592
Lee, Y.-H., 118
Lee, Y.-L., 281
Lee, Y.-S., 623
Li, G., 310
Li, J.-S., 123
Li, P.Y., 6
Li, W., 264
Li, Y., 416
Li, Z.-Z., 562
Liepmann, D., 163
Lin, B., 6
Lin, K.-W., 425
Lin, S.C., 174
Liu, C.J., 344
Liu, G., 416
Liu, J., 330, 444, 511
Liu, J.-H., 1
Liu, W.-C., 425
Liu, X., 556
Liu, Y., 416
Llobet, E., 201, 267
Longchamp, S., 516
López-Sandoval, E., 149
Lu, C.-T., 425
Lu, G., 50
Lu, H., 310
Lu, P., 264
Luo, D., 253

Ma, J., 14
Ma, J.S., 511
Marsal, A., 74
Martin, D.C., 437
Martínez Pérez, L., 149
Mathanmohan, T., 336
McFarland, E.W., 556
McGill, R.A., 223
Meng, F., 330, 444
Mertens, J., 58
Mie, M., 106
Mikkelsen, J.C., 66
Min, B.-K., 288
Mishra, A.P., 230
Mittal, S.K., 340
Montanaro, L., 141
Moon, S.-I., 118
Morante, J., 297
Morante, J.R., 74
Moriguchi, H., 156
Muñoz, D.R., 42
Muñoz Aguirre, N., 149
Muralidharan, B., 336

Na, K., 393
Nabok, A., 355
Nadal, M.-H., 58
Nagaraja, K.S., 350
Najafi, M.B., 410
Nakamoto, T., 367, 431
Nakamura, K., 361
Navarro, A.E., 42
Nefedov, V.A., 568

Elsevier B.V.
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Nicolas, J., 384
Niu, X., 399, 405

Okamoto, T., 113, 141
Onoue, K., 361

Pandey, P.C., 230
Pandey, S.S., 601
Park, J.-K., 18
Passian, A., 149
Phillips, C., 273
Pi, Z., 444
Pinnaduwage, L.A., 223
Planje, W.G., 544
Porter, T.L., 474
Pron, A., 601

Qin, M., 491
Qiu, X., 499

Raj, E.S., 350
Rajam, K.S., 459
Rat'ko, A.A., 539
Ray, A.K., 355
Reynolds, J.R., 437
Richter, A., 451, 579
Rivera, D., 480
Roldan Cuenya, B., 556
Romain, A.-C., 384

Sabelnikov, A.G., 568
Sadaoka, Y., 113, 141
Safavi, A., 608
Salazar, A., 42
Santiago, J.G., 66
Sasahara, T., 532
Sathiyamoorthi, R., 336
Schmidt-Zhang, P., 258
Schönauer, U., 373
Sengupta, S., 25
Seo, H.R., 323
Seo, J., 615
Sevastjanov, V.G., 568
Shangguan, D., 416
Shen, B., 416
Shen, G.-L., 123
Sheu, C.-Y., 281
Shi, G., 525
Shi, K.-H., 586
Shi, L., 361
Shih, J.J., 344
Shimamoto, Y., 113, 141
Shin, D.-S., 623
Simonson, R.J., 480
Singh, A.K., 36
Singh, R., 36
Song, K., 323
Srivastava, A.K., 98
Staton, A.W., 480
Stefan, R.-I., 539
Stepnowski, S., 223
Stewart, J.R., 253
Su, L., 499
Su, P.-G., 304
Sugio, Y., 156
Sun, P.-P., 586
Sun, Y., 330
Sunayama, T., 532
Sundaram, R., 350
Sung, W.J., 393
Svec, F., 66

Takahashi, K., 156
Takashima, W., 601
Tan, F., 14
Tashkhourian, J., 410
Thompson, M., 355
Thundat, T., 223
Tian, G., 310
Toko, K., 315
Tripp, J.A., 66
Tsai, Y.C., 174
Tsai, Y.-Y., 425
Tseng, F.G., 174
Tung, C., 499

Uematsu, H., 431
Uematsu, S., 532

van der Wal, P.D., 505
van Staden, J.(Koos) F., 539
Vasiliev, A., 297
Vasudevan, T., 336
Vázquez-López, C., 149
Vilanova, X., 201, 267

Wang, D.Y., 571
Wang, H., 123
Wang, J., 586
Wang, L., 330
Wang, Q., 50
Wang, X.-H., 586
Wang, Z., 264
Wei, C.-W., 186
Wilkop, T., 355
Wright, J.D., 134
Wu, F.-Q., 586
Wu, Z., 511

Xiao, C., 511
Xiao, Y., 437
Xu, W., 444

Yamanaka, T., 367
Yanagida, Y., 106
Yang, B., 14, 50
Yang, D., 310
Yang, G., 511
Yang, S., 511
Yang, T., 468
Yasuda, K., 156
Yelton, W.G., 480
Yi, J., 216
Yoshikawa, K., 367
Young, T.-H., 186
Yu, R.-Q., 123
Yu, X., 416

Zare, R.N., 216
Zeng, S., 66
Zhang, F., 499
Zhang, H., 416
Zhang, M., 468
Zhang, W., 416
Zhang, X., 30
Zhang, Z., 30
Zhao, R., 416
Zhu, Z., 310
Ziaie, B., 25
Zimmermann, S., 163

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Sensors and Actuators B 99 (2004) III–XI

SENSORS AND ACTUATORS B CHEMICAL

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Subject Index of Volume B 99

AB_5
Nickel hexacyanoferrate; Modified electrodes; Cyclic voltammetry (Longchamp, S. (99) 516)

Acetaldehyde
Cataluminescence; Gas sensor; Nanosized $BaCO_3$ (Cao, X. (99) 30)

Acidic sensor
9-(Cycloheptatrienylidene)fluorene (Wang, Z. (99) 264)

Actuator
Polypyrrole; Polythiophene; Raman spectroscopy (Han, G. (99) 525)

Adsorption
Identification; Alcohol; Catalytic combustion; Micro gas sensor; Structural isomer (Sasahara, T. (99) 532)

Adsorption
TSM quartz resonators; Impedance analysis; BVD equivalent circuit; Viscoelastic properties; Organic vapours (Holloway, A.F. (99) 355)

Agar microchamber
On-chip culture system; Photo-thermal etching; Change of structure; Neural network pattern (Sugio, Y. (99) 156)

Al_2O_3
Chemical sensor; Schottky diode; Hot electron transport; Au; MIS (Liu, X. (99) 556)

Alcohol
Identification; Adsorption; Catalytic combustion; Micro gas sensor; Structural isomer (Sasahara, T. (99) 532)

AlGaAs Schottky diode
Hydrogen sensors; Thermodynamic; Response time (Cheng, C.-C. (99) 425)

Alizarin red S
Silica sol–gel; Aluminum ions; Chemical modified electrode (Di, J. (99) 468)

Alumina-supported Pd catalyst
SnO_2-based sensor; Two-layer thick films; Combustion gas; Selectivity; Stability (Su, P.-G. (99) 304)

Aluminum ions
Alizarin red S; Silica sol–gel; Chemical modified electrode (Di, J. (99) 468)

"Allotropized" water
SPR sensor; Water; Dielectric function (Muñoz Aguirre, N. (99) 149)

Amperometric sensor
Gas sensors; Zirconia; Multi-electrode cell; Propene (Schmidt-Zhang, P. (99) 258)

2-Aminobenzothiazole
Cerium (III) ion-selective electrode; PVC membrane; Potentiometry (Akhond, M. (99) 410)

Anaesthetic
Sevoflurane; Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Oxygen; Nitrous oxide; Reduction; Microelectrode (Floate, S. (99) 236)

Artificial neural network
Electronic nose; Extraction parameter; Cigarettes odour; Cigarette brand identification (Luo, D. (99) 253)

Artificial nasal mucus
Odor sensor; Surface polarity controlling method; Partial structure; Constant phase element (Izumi, R. (99) 315)

Atomic force microscope (AFM)
Cantilever; Gas sensor; Hydrofluoric acid (HF); Silicon oxide (Mertens, J. (99) 58)

Atropisomers
Polymeric membrane; Lead cation; Ion-selective electrode; *meso*-Tetrakis(2-hydroxy-1-naphthyl)porphyrins (Lee, H.K. (99) 323)

Au
Chemical sensor; Schottky diode; Hot electron transport; Al_2O_3; MIS (Liu, X. (99) 556)

Benzene
Diamond; Gas sensor; Toluene; Schottky diode (Gurbuz, Y. (99) 207)

Bi_2O_3
Gas sensor; NO (Cabot, A. (99) 74)

Bimodal distribution
Thick film sensor; Nanophase tin dioxide; Pore structure; Crystallinity (Ahn, J.-P. (99) 18)

BioMEMS
In-device immobilization; Enzyme immobilization; Protein patterning; Glucose oxidase; Glucose sensor (Zimmermann, S. (99) 163)

Biomolecular interactions
Label-free imaging; Surface plasmon resonance (SPR) (Li, P.Y. (99) 6)

Biosensor
Glucose sensor; Polypyrrole; Hydrophobic heparin; Interference (Sung, W.J. (99) 393)

Biosensor
Surface plasmon resonance; Optical sensor; Chemical sensor (Alieva, E.V. (99) 90)

Bis(pyrrol-2-yl-methyleneamine)
Fluorescent sensor; Ratiometric; Zinc (Wu, Z. (99) 511)

Boron-doped diamond
Glucose; Glucose oxidase; Enzyme (Su, L. (99) 499)

BVD equivalent circuit
TSM quartz resonators; Impedance analysis; Viscoelastic properties; Adsorption; Organic vapours (Holloway, A.F. (99) 355)

Calcium ions
DB18C6; Membrane electrode; Potentiometric sensor; Selectivity coefficients (Kumar, A. (99) 340)

Calibration maintenance
CLS/PLS; SAW devices; Calibration (Rivera, D. (99) 480)

Calibration
CLS/PLS; SAW devices; Calibration maintenance (Rivera, D. (99) 480)

Cantilever
Gas sensor; Hydrofluoric acid (HF); Silicon oxide; Atomic force microscope (AFM) (Mertens, J. (99) 58)

Capacitive sensor
CMOS sensor; Humidity sensor; Reliability; Polyimide film (Gu, L. (99) 491)

Carbon monoxide
Microcantilever; Piezoresistive; Embedded (Kooser, A. (99) 474)

Carbon monoxide
Sensor; Hydrogen; Fuel cell; Polymer (Planje, W.G. (99) 544)

Cataluminescence
Acetaldehyde; Gas sensor; Nanosized $BaCO_3$ (Cao, X. (99) 30)

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Catalysis
Oxygen sensor; Oxygen–hydrogen reaction; Thermal sensing resistor (Tan, F. (99) 14)
Catalytic combustion
Identification; Alcohol; Adsorption; Micro gas sensor; Structural isomer (Sasahara, T. (99) 532)
Cell-based assessing system
Inducible nitric oxide synthase; Nitric oxide; Polyion complex (Kamei, K.-i. (99) 106)
Cerium (III) ion-selective electrode
2-Aminobenzothiazole; PVC membrane; Potentiometry (Akhond, M. (99) 410)
Change of structure
On-chip culture system; Agar microchamber; Photo-thermal etching; Neural network pattern (Sugio, Y. (99) 156)
Chemical modified electrode
Alizarin red S; Silica sol–gel; Aluminum ions (Di, J. (99) 468)
Chemical sensor
Surface plasmon resonance; Biosensor; Optical sensor (Alieva, E.V. (99) 90)
Chemical sensor
Infrared sensor; Multicomponent diffusion; Maxwell–Stefan (Phillips, C. (99) 273)
Chemical sensor
Schottky diode; Hot electron transport; Au; Al_2O_3; MIS (Liu, X. (99) 556)
Chemisorption layer
1-Pyrenedecanoic acid; Perfluorodecanoic acid; Fluorescence; Stern–Volmer equation (Fujiwara, Y. (99) 130)
Chitosan/alginate sensitive membrane
Cysteamine SAM; Method of immobilization; Piezoelectric immunosensors; Factor B (Deng, T. (99) 123)
Cigarette brand identification
Artificial neural network; Electronic nose; Extraction parameter; Cigarettes odour (Luo, D. (99) 253)
Cigarettes odour
Artificial neural network; Electronic nose; Extraction parameter; Cigarette brand identification (Luo, D. (99) 253)
Cl_2 sensing
$ZnFe_2O_4$; Microemulsion; Semiconductor; Spinel-type oxide (Niu, X. (99) 405)
CLS/PLS
SAW devices; Calibration; Calibration maintenance (Rivera, D. (99) 480)
CMOS sensor
Humidity sensor; Capacitive sensor; Reliability; Polyimide film (Gu, L. (99) 491)
CMOS
High-density microelectrode arrays; Electrophysiology; Gold electroless (Berdondini, L. (99) 505)
CO
Electrochemical sensor; Multi-wall carbon nanotubes; Self-assembled electrode; Determination (He, J.-B. (99) 1)
CO_2 gas sensor
Sodium-aluminosilicates; Lithium silicates; Y-stabilized zirconia; Li_2CO_3; Electromotive force (Shimamoto, Y. (99) 113)
CO_2 gas sensor
Sodium-aluminosilicates; Y-stabilised zirconia; Na_2CO_3; Electromotive force (Shimamoto, Y. (99) 141)
Coated wire ion-selective electrode
Lead; 5,11,17,23,29,35-Hexa-*tert*-butyl-37,38,39,40,41,42-hexahydroxycalix[6]arene; Potentiometry (Bhat, V.S. (99) 98)
Color chemical reaction
Explosives detection and quantification; Sensitive film (Dorozhkin, L.M. (99) 568)
Combustion gas
SnO_2-based sensor; Two-layer thick films; Alumina-supported Pd catalyst; Selectivity; Stability (Su, P.-G. (99) 304)
Combustion synthesis
Samarium chromium oxide; Microwave synthesis; Humidity sensors (Sundaram, R. (99) 350)
Compensation methods
ISFET; Long-term drift; Instrumentation systems; Hysteresis; Electronic conditioning (Casans, S. (99) 42)
Composite material
Lanthanum ferrite; Humidity sensor; Humidity sensing property; Water resistance property (Wang, J. (99) 586)
Composites
Tin oxide; Gas sensor; NASICON; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Compost
Electronic nose; Environment; Odour; Limit of detection; Resolution limits (Nicolas, J. (99) 384)
Constant phase element
Odor sensor; Surface polarity controlling method; Partial structure; Artificial nasal mucus (Izumi, R. (99) 315)
Conducting polymer
Electrochemical polymerization; Surface modification; Poly(3,4-ethylenedioxythiophene) derivatives; Neural probes (Xiao, Y. (99) 437)
Contact angle
Fluorocarbon film; Lift-off process; Protein patterning; Nonspecific binding (Lee, S.-H. (99) 623)
Copper(II)
Piezo-optical sensor; Eriochrome cyanine R; Sol–gel (Wright, J.D. (99) 134)
Creatinine
Polyaniline; pH sensor; Ormosil; Potentiometry (Pandey, P.C. (99) 230)
Crystallinity
Thick film sensor; Nanophase tin dioxide; Pore structure; Bimodal distribution (Ahn, J.-P. (99) 18)
Crystallite growth inhibition
Free CaO; STEM image; EELS microphotograph; Segregation (Min, B.-K. (99) 288)
CVD
Multi-walled carbon nanotube; Gas sensor; Lateral growth (Jang, Y.-T. (99) 118)
Cyclic voltammetry
AB_5; Nickel hexacyanoferrate; Modified electrodes (Longchamp, S. (99) 516)
Cysteamine SAM
Chitosan/alginate sensitive membrane; Method of immobilization; Piezoelectric immunosensors; Factor B (Deng, T. (99) 123)

DB18C6
Membrane electrode; Potentiometric sensor; Calcium ions; Selectivity coefficients (Kumar, A. (99) 340)
Detection
Dinitrotoluene (DNT); Microcantilever; Microsensor (Pinnaduwage, L.A. (99) 223)
Determination
Electrochemical sensor; Multi-wall carbon nanotubes; Self-assembled electrode; CO (He, J.-B. (99) 1)
Diamond
Gas sensor; Benzene; Toluene; Schottky diode (Gurbuz, Y. (99) 207)
Dielectric function
SPR sensor; "Allotropized" water; Water (Muñoz Aguirre, N. (99) 149)
Dinitrotoluene (DNT)
Microcantilever; Microsensor; Detection (Pinnaduwage, L.A. (99) 223)
Direct chemistry
Hemoglobin; Sol–gel film; H_2O_2 biosensor (Wang, Q. (99) 50)
Dithizone
Optode; Hg^{2+} ions; Iodide (Safavi, A. (99) 608)
Dopants and platinum
Ethanol detection; Tin dioxide; Gas sensing; High sensitivity (Ivanov, P. (99) 201)

Dynamic measurement
Gas sensing behavior; Influencing factors (Huang, X. (99) 444)

EELS microphotograph
Crystallite growth inhibition; Free CaO; STEM image; Segregation (Min, B.-K. (99) 288)
Electrochemical polymerization
Surface modification; Conducting polymer; Poly(3,4-ethylenedioxythiophene) derivatives; Neural probes (Xiao, Y. (99) 437)
Electrochemical sensor
Multi-wall carbon nanotubes; Self-assembled electrode; CO; Determination (He, J.-B. (99) 1)
Electrochemomechanical deformation
Polyaniline; Soft actuator; pH dependence; Temperature dependence; Load effect (Takashima, W. (99) 601)
Electrode dynamics
Oxygen sensor; Zirconia; Platinum electrode (Wang, D.Y. (99) 571)
Electromotive force
Sodium-aluminosilicates; Lithium silicates; Y-stabilized zirconia; Li_2CO_3; CO_2 gas sensor (Shimamoto, Y. (99) 113)
Electromotive force
Sodium-aluminosilicates; Y-stabilised zirconia; Na_2CO_3; CO_2 gas sensor (Shimamoto, Y. (99) 141)
Electronic conditioning
ISFET; Long-term drift; Instrumentation systems; Compensation methods; Hysteresis (Casans, S. (99) 42)
Electronic nose
Artificial neural network; Extraction parameter; Cigarettes odour; Cigarette brand identification (Luo, D. (99) 253)
Electronic nose
Environment; Odour; Limit of detection; Resolution limits; Compost (Nicolas, J. (99) 384)
Electroosmotic pumps
Porous; Polymer; Monolith (Tripp, J.A. (99) 66)
Electrophoresis
Time-of-flight; Flow sensor; Protein (Sengupta, S. (99) 25)
Electrophysiology
High-density microelectrode arrays; Gold electroless; CMOS (Berdondini, L. (99) 505)
ELISA
Quartz crystal biosensor; Kinetic analysis; Human TNF-α; Genetic algorithm (Liu, Y. (99) 416)
Embedded
Microcantilever; Piezoresistive; Carbon monoxide (Kooser, A. (99) 474)
Enantioselective
Potentiometric membrane electrode; Macrocyclic antibiotics; Vancomycin; D-Pipecolic acid (Rat'ko, A.A. (99) 539)
Environment
Electronic nose; Odour; Limit of detection; Resolution limits; Compost (Nicolas, J. (99) 384)
Enzyme immobilization
In-device immobilization; Protein patterning; Glucose oxidase; Glucose sensor; BioMEMS (Zimmermann, S. (99) 163)
Enzyme
Glucose; Boron-doped diamond; Glucose oxidase (Su, L. (99) 499)
Eriochrome cyanine R
Piezo-optical sensor; Copper(II); Sol–gel (Wright, J.D. (99) 134)
Ethanol detection
Tin dioxide; Gas sensing; High sensitivity; Dopants and platinum (Ivanov, P. (99) 201)
Explosives detection and quantification
Sensitive film; Color chemical reaction (Dorozhkin, L.M. (99) 568)
Extraction parameter
Artificial neural network; Electronic nose; Cigarettes odour; Cigarette brand identification (Luo, D. (99) 253)

Factor B
Cysteamine SAM; Chitosan/alginate sensitive membrane; Method of immobilization; Piezoelectric immunosensors (Deng, T. (99) 123)
Ferrofluid
Valve; Pump; Microfluidic; Lab-on-a-chip (Hartshorne, H. (99) 592)
Film structure
In_2O_3; Spray pyrolysis; Gas response; Ozone (Korotcenkov, G. (99) 297)
Film thickness
Phthalocyanine; Vacuum deposition; Gas sensor; Sensing temperature (Lee, Y.-L. (99) 281)
Flow sensor
Time-of-flight; Electrophoresis; Protein (Sengupta, S. (99) 25)
Fluorescence quenching
Pyrene derivative; Pressure sensitive paint; Oxygen sensor (Basu, B.J. (99) 459)
Fluorescence
1-Pyrenedecanoic acid; Chemisorption layer; Perfluorodecanoic acid; Stern–Volmer equation (Fujiwara, Y. (99) 130)
Fluorescent biosensor
Integrated biophotonic chips; Integrated microfluidics; Planar microlens (Seo, J. (99) 615)
Fluorescent sensor
Ratiometric; Bis(pyrrol-2-yl-methyleneamine); Zinc (Wu, Z. (99) 511)
Fluorine
Sensors; Gases; Polymer electrolyte; V_2O_5 and electrochemical cell (Sathiyamoorthi, R. (99) 336)
Fluorocarbon film
Lift-off process; Contact angle; Protein patterning; Nonspecific binding (Lee, S.-H. (99) 623)
Fluoroimmunosensing
Prochlorperazine; Transferrin (Li, Z.-Z. (99) 562)
Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether
Sevoflurane; Anaesthetic; Oxygen; Nitrous oxide; Reduction; Microelectrode (Floate, S. (99) 236)
Free CaO
Crystallite growth inhibition; STEM image; EELS microphotograph; Segregation (Min, B.-K. (99) 288)
Fuel cell
Sensor; Carbon monoxide; Hydrogen; Polymer (Planje, W.G. (99) 544)
Fuzzy ARTMAP
Genetic algorithm; Variable selection; Gas sensor array (Llobet, E. (99) 267)

Gas analysis
SnO_2 gas sensor; Modulating temperature; Pesticide residue (Huang, X. (99) 330)
Gas response
In_2O_3; Film structure; Spray pyrolysis; Ozone (Korotcenkov, G. (99) 297)
Gas sensing behavior
Dynamic measurement; Influencing factors (Huang, X. (99) 444)
Gas sensing
Ethanol detection; Tin dioxide; High sensitivity; Dopants and platinum (Ivanov, P. (99) 201)
Gas sensor array
Genetic algorithm; Fuzzy ARTMAP; Variable selection (Llobet, E. (99) 267)
Gas sensor
Bi_2O_3; NO (Cabot, A. (99) 74)
Gas sensor
Cantilever; Hydrofluoric acid (HF); Silicon oxide; Atomic force microscope (AFM) (Mertens, J. (99) 58)
Gas sensor
Cataluminescence; Acetaldehyde; Nanosized $BaCO_3$ (Cao, X. (99) 30)
Gas sensor
Diamond; Benzene; Toluene; Schottky diode (Gurbuz, Y. (99) 207)

Gas sensor
Multi-walled carbon nanotube; Lateral growth; CVD (Jang, Y.-T. (99) 118)
Gas sensor
Nickel phthalocyanine; Vacuum deposition; Morphology (Liu, C.J. (99) 344)
Gas sensor
Phthalocyanine; Vacuum deposition; Film thickness; Sensing temperature (Lee, Y.-L. (99) 281)
Gas sensor
Tin oxide; NASICON; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Gas sensors
Amperometric sensor; Zirconia; Multi-electrode cell; Propene (Schmidt-Zhang, P. (99) 258)
Gas-sensing property
$REFeO_3$; Nanometer materials; Gasoline sensor (Niu, X. (99) 399)
Gases
Sensors; Fluorine; Polymer electrolyte; V_2O_5 and electrochemical cell (Sathiyamoorthi, R. (99) 336)
Gasoline sensor
$REFeO_3$; Nanometer materials; Gas-sensing property (Niu, X. (99) 399)
Genetic algorithm
Fuzzy ARTMAP; Variable selection; Gas sensor array (Llobet, E. (99) 267)
Genetic algorithm
Quartz crystal biosensor; Kinetic analysis; Human TNF-α; ELISA (Liu, Y. (99) 416)
Glucose oxidase
Glucose; Boron-doped diamond; Enzyme (Su, L. (99) 499)
Glucose oxidase
In-device immobilization; Enzyme immobilization; Protein patterning; Glucose sensor; BioMEMS (Zimmermann, S. (99) 163)
Glucose sensor
Biosensor; Polypyrrole; Hydrophobic heparin; Interference (Sung, W.J. (99) 393)
Glucose sensor
In-device immobilization; Enzyme immobilization; Protein patterning; Glucose oxidase; BioMEMS (Zimmermann, S. (99) 163)
Glucose
Boron-doped diamond; Glucose oxidase; Enzyme (Su, L. (99) 499)
Gold electroless
High-density microelectrode arrays; Electrophysiology; CMOS (Berdondini, L. (99) 505)
H_2O_2 biosensor
Hemoglobin; Sol–gel film; Direct chemistry (Wang, Q. (99) 50)
Halitosis
QCM; Preconcentrator; VSCs; Odor sensing system (Ito, J. (99) 431)
Hemoglobin
Sol–gel film; Direct chemistry; H_2O_2 biosensor (Wang, Q. (99) 50)
1,6-Hexanedithiol
Mercuric ions; SPR; Selective detection (Chah, S. (99) 216)
Hg^{2+} ions
Optode; Iodide; Dithizone (Safavi, A. (99) 608)
5,11,17,23,29,35-Hexa-*tert*-butyl-37,38,39,40,41,42-hexahydroxycalix[6]-arene
Coated wire ion-selective electrode; Lead; Potentiometry (Bhat, V.S. (99) 98)
High sensitivity
Ethanol detection; Tin dioxide; Gas sensing; Dopants and platinum (Ivanov, P. (99) 201)
High sensitivity
SnO_2 sensor; RF induction plasma deposition; XRD; SEM (Shi, L. (99) 361)
High-density microelectrode arrays
Electrophysiology; Gold electroless; CMOS (Berdondini, L. (99) 505)
Hot electron transport
Chemical sensor; Schottky diode; Au; Al_2O_3; MIS (Liu, X. (99) 556)
Human TNF-α
Quartz crystal biosensor; Kinetic analysis; Genetic algorithm; ELISA (Liu, Y. (99) 416)
Humidity sensing property
Lanthanum ferrite; Composite material; Humidity sensor; Water resistance property (Wang, J. (99) 586)
Humidity sensor
CMOS sensor; Capacitive sensor; Reliability; Polyimide film (Gu, L. (99) 491)
Humidity sensor
Lanthanum ferrite; Composite material; Humidity sensing property; Water resistance property (Wang, J. (99) 586)
Humidity sensors
Samarium chromium oxide; Microwave synthesis; Combustion synthesis (Sundaram, R. (99) 350)
Hydrofluoric acid (HF)
Cantilever; Gas sensor; Silicon oxide; Atomic force microscope (AFM) (Mertens, J. (99) 58)
Hydrogel application
Smart hydrogel; Hydrogel sensor; Phase transition; Quartz crystal microbalance; pH sensor; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)
Hydrogel sensor
Smart hydrogel; Hydrogel application; Phase transition; Quartz crystal microbalance; pH sensor; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)
Hydrogen sensors
AlGaAs Schottky diode; Thermodynamic; Response time (Cheng, C.-C. (99) 425)
Hydrogen
Sensor; Carbon monoxide; Fuel cell; Polymer (Planje, W.G. (99) 544)
Hydrophobic heparin
Glucose sensor; Biosensor; Polypyrrole; Interference (Sung, W.J. (99) 393)
Hysteresis
ISFET; Long-term drift; Instrumentation systems; Compensation methods; Electronic conditioning (Casans, S. (99) 42)

Identification
Alcohol; Adsorption; Catalytic combustion; Micro gas sensor; Structural isomer (Sasahara, T. (99) 532)
Impedance analysis
TSM quartz resonators; BVD equivalent circuit; Viscoelastic properties; Adsorption; Organic vapours (Holloway, A.F. (99) 355)
In-device immobilization
Enzyme immobilization; Protein patterning; Glucose oxidase; Glucose sensor; BioMEMS (Zimmermann, S. (99) 163)
In_2O_3
Film structure; Spray pyrolysis; Gas response; Ozone (Korotcenkov, G. (99) 297)
Inducible nitric oxide synthase
Cell-based assessing system; Nitric oxide; Polyion complex (Kamei, K.-i. (99) 106)
Influencing factors
Dynamic measurement; Gas sensing behavior (Huang, X. (99) 444)
Infrared sensor
Chemical sensor; Multicomponent diffusion; Maxwell–Stefan (Phillips, C. (99) 273)
Instrumentation systems
ISFET; Long-term drift; Compensation methods; Hysteresis; Electronic conditioning (Casans, S. (99) 42)
Integrated biophotonic chips
Integrated microfluidics; Fluorescent biosensor; Planar microlens (Seo, J. (99) 615)

Integrated microfluidics
Integrated biophotonic chips; Fluorescent biosensor; Planar microlens (Seo, J. (99) 615)
Interference
Glucose sensor; Biosensor; Polypyrrole; Hydrophobic heparin (Sung, W.J. (99) 393)
Iodide
Optode; Hg^{2+} ions; Dithizone (Safavi, A. (99) 608)
Ion-selective electrode
Polymeric membrane; Lead cation; *meso*-Tetrakis(2-hydroxy-1-naphthyl)porphyrins; Atropisomers (Lee, H.K. (99) 323)
Ionic conductor
Tin oxide; Gas sensor; NASICON; Composites; Solid electrolyte; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
ISFET
Long-term drift; Instrumentation systems; Compensation methods; Hysteresis; Electronic conditioning (Casans, S. (99) 42)

Kinetic analysis
Quartz crystal biosensor; Human TNF-α; Genetic algorithm; ELISA (Liu, Y. (99) 416)

Lab-on-a-chip
Ferrofluid; Valve; Pump; Microfluidic (Hartshorne, H. (99) 592)
Label-free imaging
Biomolecular interactions; Surface plasmon resonance (SPR) (Li, P.Y. (99) 6)
Lanthanum ferrite
Composite material; Humidity sensor; Humidity sensing property; Water resistance property (Wang, J. (99) 586)
Laser-micromachining
PMMA modification; Microfluidic biochip (Cheng, J.-Y. (99) 186)
Lateral growth
Multi-walled carbon nanotube; Gas sensor; CVD (Jang, Y.-T. (99) 118)
Lead cation
Polymeric membrane; Ion-selective electrode; *meso*-Tetrakis(2-hydroxy-1-naphthyl)porphyrins; Atropisomers (Lee, H.K. (99) 323)
Lead
Coated wire ion-selective electrode; 5,11,17,23,29,35-Hexa-*tert*-butyl-37,38,39,40,41,42-hexahydroxycalix[6]arene; Potentiometry (Bhat, V.S. (99) 98)
Li_2CO_3
Sodium-aluminosilicates; Lithium silicates; Y-stabilized zirconia; Electromotive force; CO_2 gas sensor (Shimamoto, Y. (99) 113)
Lift-off process
Fluorocarbon film; Contact angle; Protein patterning; Nonspecific binding (Lee, S.-H. (99) 623)
Limit of detection
Electronic nose; Environment; Odour; Resolution limits; Compost (Nicolas, J. (99) 384)
Lithium silicates
Sodium-aluminosilicates; Y-stabilized zirconia; Li_2CO_3; Electromotive force; CO_2 gas sensor (Shimamoto, Y. (99) 113)
Load effect
Polyaniline; Electrochemomechanical deformation; Soft actuator; pH dependence; Temperature dependence (Takashima, W. (99) 601)
Long-term drift
ISFET; Instrumentation systems; Compensation methods; Hysteresis; Electronic conditioning (Casans, S. (99) 42)

Macro cyclic ionophore
Mercury selective electrode; Potentiometric sensor (Singh, A.K. (99) 36)
Macrocyclic antibiotics
Enantioselective; Potentiometric membrane electrode; Vancomycin; D-Pipecolic acid (Rat'ko, A.A. (99) 539)
Maxwell–Stefan
Chemical sensor; Infrared sensor; Multicomponent diffusion (Phillips, C. (99) 273)
Membrane electrode
DB18C6; Potentiometric sensor; Calcium ions; Selectivity coefficients (Kumar, A. (99) 340)
Mercuric ions
SPR; 1,6-Hexanedithiol; Selective detection (Chah, S. (99) 216)
Mercury selective electrode
Macro cyclic ionophore; Potentiometric sensor (Singh, A.K. (99) 36)
meso-Tetrakis(2-hydroxy-1-naphthyl)porphyrins
Polymeric membrane; Lead cation; Ion-selective electrode; Atropisomers (Lee, H.K. (99) 323)
Method of immobilization
Cysteamine SAM; Chitosan/alginate sensitive membrane; Piezoelectric immunosensors; Factor B (Deng, T. (99) 123)
Micro gas sensor
Identification; Alcohol; Adsorption; Catalytic combustion; Structural isomer (Sasahara, T. (99) 532)
Micro stamp
Protein micro array; Protein chip; Soft lithography; Surface tension (Lin, S.C. (99) 174)
Microcantilever
Dinitrotoluene (DNT); Microsensor; Detection (Pinnaduwage, L.A. (99) 223)
Microcantilever
Piezoresistive; Embedded; Carbon monoxide (Kooser, A. (99) 474)
Microelectrode
Sevoflurane; Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Anaesthetic; Oxygen; Nitrous oxide; Reduction (Floate, S. (99) 236)
Microemulsion
Cl_2 sensing; $ZnFe_2O_4$; Semiconductor; Spinel-type oxide (Niu, X. (99) 405)
Microfluidic biochip
Laser-micromachining; PMMA modification (Cheng, J.-Y. (99) 186)
Microfluidic
Ferrofluid; Valve; Pump; Lab-on-a-chip (Hartshorne, H. (99) 592)
Microsensor
Dinitrotoluene (DNT); Microcantilever; Detection (Pinnaduwage, L.A. (99) 223)
Microvalve
Smart hydrogel; Valve; Operation mode; Phenomena of volume phase transition (Richter, A. (99) 451)
Microwave synthesis
Samarium chromium oxide; Combustion synthesis; Humidity sensors (Sundaram, R. (99) 350)
MIS
Chemical sensor; Schottky diode; Hot electron transport; Au; Al_2O_3 (Liu, X. (99) 556)
Mixture quantification
Odor-sensing system; QCM sensor array; Real-time monitoring (Yamanaka, T. (99) 367)
Modified electrodes
AB_5; Nickel hexacyanoferrate; Cyclic voltammetry (Longchamp, S. (99) 516)
Modulating temperature
SnO_2 gas sensor; Pesticide residue; Gas analysis (Huang, X. (99) 330)
Monolith
Electroosmotic pumps; Porous; Polymer (Tripp, J.A. (99) 66)
Morphology
Nickel phthalocyanine; Vacuum deposition; Gas sensor (Liu, C.J. (99) 344)
Multi-electrode cell
Gas sensors; Amperometric sensor; Zirconia; Propene (Schmidt-Zhang, P. (99) 258)

Multi-wall carbon nanotubes
Electrochemical sensor; Self-assembled electrode; CO; Determination (He, J.-B. (99) 1)
Multi-walled carbon nanotube
Gas sensor; Lateral growth; CVD (Jang, Y.-T. (99) 118)
Multicomponent diffusion
Chemical sensor; Infrared sensor; Maxwell–Stefan (Phillips, C. (99) 273)

Na_2CO_3
Sodium-aluminosilicates; Y-stabilised zirconia; CO_2 gas sensor; Electromotive force (Shimamoto, Y. (99) 141)
Nanometer materials
$REFeO_3$; Gas-sensing property; Gasoline sensor (Niu, X. (99) 399)
Nanophase tin dioxide
Thick film sensor; Pore structure; Crystallinity; Bimodal distribution (Ahn, J.-P. (99) 18)
Nanosized $BaCO_3$
Cataluminescence; Acetaldehyde; Gas sensor (Cao, X. (99) 30)
NASICON
Tin oxide; Gas sensor; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Neural network pattern
On-chip culture system; Agar microchamber; Photo-thermal etching; Change of structure (Sugio, Y. (99) 156)
Neural probes
Electrochemical polymerization; Surface modification; Conducting polymer; Poly(3,4-ethylenedioxythiophene) derivatives (Xiao, Y. (99) 437)
Nickel hexacyanoferrate
AB_5; Modified electrodes; Cyclic voltammetry (Longchamp, S. (99) 516)
Nickel phthalocyanine
Vacuum deposition; Gas sensor; Morphology (Liu, C.J. (99) 344)
Nitric oxide
Cell-based assessing system; Inducible nitric oxide synthase; Polyion complex (Kamei, K.-i. (99) 106)
Nitrous oxide
Sevoflurane; Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Anaesthetic; Oxygen; Reduction; Microelectrode (Floate, S. (99) 236)
NO
Bi_2O_3; Gas sensor (Cabot, A. (99) 74)
Nonspecific binding
Fluorocarbon film; Lift-off process; Contact angle; Protein patterning (Lee, S.-H. (99) 623)

Odor sensing system
Halitosis; QCM; Preconcentrator; VSCs (Ito, J. (99) 431)
Odor sensor
Surface polarity controlling method; Partial structure; Artificial nasal mucus; Constant phase element (Izumi, R. (99) 315)
Odor-sensing system
QCM sensor array; Mixture quantification; Real-time monitoring (Yamanaka, T. (99) 367)
Odour
Electronic nose; Environment; Limit of detection; Resolution limits; Compost (Nicolas, J. (99) 384)
On-chip culture system
Agar microchamber; Photo-thermal etching; Change of structure; Neural network pattern (Sugio, Y. (99) 156)
Operation mode
Smart hydrogel; Valve; Microvalve; Phenomena of volume phase transition (Richter, A. (99) 451)
Optical sensor
Surface plasmon resonance; Biosensor; Chemical sensor (Alieva, E.V. (99) 90)
Optode
Hg^{2+} ions; Iodide; Dithizone (Safavi, A. (99) 608)
Organic vapours
TSM quartz resonators; Impedance analysis; BVD equivalent circuit; Viscoelastic properties; Adsorption (Holloway, A.F. (99) 355)
Ormosil
Polyaniline; pH sensor; Creatinine; Potentiometry (Pandey, P.C. (99) 230)
Oxygen sensor
Electrode dynamics; Zirconia; Platinum electrode (Wang, D.Y. (99) 571)
Oxygen sensor
Pyrene derivative; Fluorescence quenching; Pressure sensitive paint (Basu, B.J. (99) 459)
Oxygen
Sevoflurane; Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Anaesthetic; Nitrous oxide; Reduction; Microelectrode (Floate, S. (99) 236)
Oxygen–hydrogen reaction
Oxygen sensor; Thermal sensing resistor; Catalysis (Tan, F. (99) 14)
Oxygen sensor
Oxygen–hydrogen reaction; Thermal sensing resistor; Catalysis (Tan, F. (99) 14)
Ozone
In_2O_3; Film structure; Spray pyrolysis; Gas response (Korotcenkov, G. (99) 297)

Partial structure
Odor sensor; Surface polarity controlling method; Artificial nasal mucus; Constant phase element (Izumi, R. (99) 315)
Perfluorodecanoic acid
1-Pyrenedecanoic acid; Chemisorption layer; Fluorescence; Stern–Volmer equation (Fujiwara, Y. (99) 130)
Pesticide residue
SnO_2 gas sensor; Modulating temperature; Gas analysis (Huang, X. (99) 330)
pH dependence
Polyaniline; Electrochemomechanical deformation; Soft actuator; Temperature dependence; Load effect (Takashima, W. (99) 601)
pH sensor
Polyaniline; Creatinine; Ormosil; Potentiometry (Pandey, P.C. (99) 230)
pH sensor
Smart hydrogel; Hydrogel sensor; Hydrogel application; Phase transition; Quartz crystal microbalance; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)
Phase transition
Smart hydrogel; Hydrogel sensor; Hydrogel application; Quartz crystal microbalance; pH sensor; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)
Phenomena of volume phase transition
Smart hydrogel; Valve; Microvalve; Operation mode (Richter, A. (99) 451)
Photo-thermal etching
On-chip culture system; Agar microchamber; Change of structure; Neural network pattern (Sugio, Y. (99) 156)
Phthalocyanine
Vacuum deposition; Gas sensor; Film thickness; Sensing temperature (Lee, Y.-L. (99) 281)
Piezo-optical sensor
Copper(II); Eriochrome cyanine R; Sol–gel (Wright, J.D. (99) 134)
Piezoelectric immunosensors
Cysteamine SAM; Chitosan/alginate sensitive membrane; Method of immobilization; Factor B (Deng, T. (99) 123)
Piezoresistive
Microcantilever; Embedded; Carbon monoxide (Kooser, A. (99) 474)
D-Pipecolic acid
Enantioselective; Potentiometric membrane electrode; Macrocyclic antibiotics; Vancomycin (Rat'ko, A.A. (99) 539)

Planar microlens
Integrated biophotonic chips; Integrated microfluidics; Fluorescent biosensor (Seo, J. (99) 615)
Platinum electrode
Oxygen sensor; Electrode dynamics; Zirconia (Wang, D.Y. (99) 571)
PMMA modification
Laser-micromachining; Microfluidic biochip (Cheng, J.-Y. (99) 186)
Poly(3,4-ethylenedioxythiophene) derivatives
Electrochemical polymerization; Surface modification; Conducting polymer; Neural probes (Xiao, Y. (99) 437)
Poly(acrylic acid)
Smart hydrogel; Hydrogel sensor; Hydrogel application; Phase transition; Quartz crystal microbalance; pH sensor; Poly(vinyl alcohol) (Richter, A. (99) 579)
Poly(vinyl alcohol)
Smart hydrogel; Hydrogel sensor; Hydrogel application; Phase transition; Quartz crystal microbalance; pH sensor; Poly(acrylic acid) (Richter, A. (99) 579)
Polyaniline
Electrochemomechanical deformation; Soft actuator; pH dependence; Temperature dependence; Load effect (Takashima, W. (99) 601)
Polyaniline
pH sensor; Creatinine; Ormosil; Potentiometry (Pandey, P.C. (99) 230)
Polyimide film
CMOS sensor; Humidity sensor; Capacitive sensor; Reliability (Gu, L. (99) 491)
Polyion complex
Cell-based assessing system; Inducible nitric oxide synthase; Nitric oxide (Kamei, K.-i. (99) 106)
Polymer electrolyte
Sensors; Gases; Fluorine; V_2O_5 and electrochemical cell (Sathiyamoorthi, R. (99) 336)
Polymer
Electroosmotic pumps; Porous; Monolith (Tripp, J.A. (99) 66)
Polymer
Sensor; Carbon monoxide; Hydrogen; Fuel cell (Planje, W.G. (99) 544)
Polymeric membrane
Lead cation; Ion-selective electrode; *meso*-Tetrakis(2-hydroxy-1-naphthyl)porphyrins; Atropisomers (Lee, H.K. (99) 323)
Polypyrrole
Glucose sensor; Biosensor; Hydrophobic heparin; Interference (Sung, W.J. (99) 393)
Polypyrrole
Polythiophene; Actuator; Raman spectroscopy (Han, G. (99) 525)
Polythiophene
Polypyrrole; Actuator; Raman spectroscopy (Han, G. (99) 525)
Pore structure
Thick film sensor; Nanophase tin dioxide; Crystallinity; Bimodal distribution (Ahn, J.-P. (99) 18)
Porous
Electroosmotic pumps; Polymer; Monolith (Tripp, J.A. (99) 66)
Potentiometric membrane electrode
Enantioselective; Macrocyclic antibiotics; Vancomycin; D-Pipecolic acid (Rat'ko, A.A. (99) 539)
Potentiometric sensor
DB18C6; Membrane electrode; Calcium ions; Selectivity coefficients (Kumar, A. (99) 340)
Potentiometric sensor
Mercury selective electrode; Macro cyclic ionophore (Singh, A.K. (99) 36)
Potentiometry
Cerium (III) ion-selective electrode; 2-Aminobenzothiazole; PVC membrane (Akhond, M. (99) 410)
Potentiometry
Coated wire ion-selective electrode; Lead; 5,11,17,23,29,35-Hexa-*tert*-butyl-37,38,39,40,41,42-hexahydroxycalix[6]arene (Bhat, V.S. (99) 98)
Potentiometry
Polyaniline; pH sensor; Creatinine; Ormosil (Pandey, P.C. (99) 230)
Preconcentrator
Halitosis; QCM; VSCs; Odor sensing system (Ito, J. (99) 431)
Pressure sensitive paint
Pyrene derivative; Fluorescence quenching; Oxygen sensor (Basu, B.J. (99) 459)
Prochlorperazine
Fluoroimmunosensing; Transferrin (Li, Z.-Z. (99) 562)
Propene
Gas sensors; Amperometric sensor; Zirconia; Multi-electrode cell (Schmidt-Zhang, P. (99) 258)
Protein chip
Protein micro array; Soft lithography; Micro stamp; Surface tension (Lin, S.C. (99) 174)
Protein micro array
Protein chip; Soft lithography; Micro stamp; Surface tension (Lin, S.C. (99) 174)
Protein patterning
Fluorocarbon film; Lift-off process; Contact angle; Nonspecific binding (Lee, S.-H. (99) 623)
Protein patterning
In-device immobilization; Enzyme immobilization; Glucose oxidase; Glucose sensor; BioMEMS (Zimmermann, S. (99) 163)
Protein
Time-of-flight; Flow sensor; Electrophoresis (Sengupta, S. (99) 25)
Pump
Ferrofluid; Valve; Microfluidic; Lab-on-a-chip (Hartshorne, H. (99) 592)
PVC membrane
Cerium (III) ion-selective electrode; 2-Aminobenzothiazole; Potentiometry (Akhond, M. (99) 410)
Pyrene derivative
Fluorescence quenching; Pressure sensitive paint; Oxygen sensor (Basu, B.J. (99) 459)
1-Pyrenedecanoic acid
Chemisorption layer; Perfluorodecanoic acid; Fluorescence; Stern–Volmer equation (Fujiwara, Y. (99) 130)

QCM sensor array
Odor-sensing system; Mixture quantification; Real-time monitoring (Yamanaka, T. (99) 367)
QCM
Halitosis; Preconcentrator; VSCs; Odor sensing system (Ito, J. (99) 431)
Quartz crystal biosensor
Kinetic analysis; Human TNF-α; Genetic algorithm; ELISA (Liu, Y. (99) 416)
Quartz crystal microbalance
Smart hydrogel; Hydrogel sensor; Hydrogel application; Phase transition; pH sensor; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)

Raman spectroscopy
Polypyrrole; Polythiophene; Actuator (Han, G. (99) 525)
Ratio of output signals
Resistance sensors; Two sensors circuit (Hu, X. (99) 310)
Ratiometric
Fluorescent sensor; Bis(pyrrol-2-yl-methyleneamine); Zinc (Wu, Z. (99) 511)
Real-time monitoring
Odor-sensing system; QCM sensor array; Mixture quantification (Yamanaka, T. (99) 367)
Reduction
Sevoflurane; Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Anaesthetic; Oxygen; Nitrous oxide; Microelectrode (Floate, S. (99) 236)

$REFeO_3$
Nanometer materials; Gas-sensing property; Gasoline sensor (Niu, X. (99) 399)
Reliability
CMOS sensor; Humidity sensor; Capacitive sensor; Polyimide film (Gu, L. (99) 491)
Resistance sensors
Ratio of output signals; Two sensors circuit (Hu, X. (99) 310)
Resolution limits
Electronic nose; Environment; Odour; Limit of detection; Compost (Nicolas, J. (99) 384)
Response time
Hydrogen sensors; AlGaAs Schottky diode; Thermodynamic (Cheng, C.-C. (99) 425)
RF induction plasma deposition
SnO_2 sensor; XRD; SEM; High sensitivity (Shi, L. (99) 361)

Samarium chromium oxide
Microwave synthesis; Combustion synthesis; Humidity sensors (Sundaram, R. (99) 350)
SAW devices
CLS/PLS; Calibration; Calibration maintenance (Rivera, D. (99) 480)
Schottky diode
Chemical sensor; Hot electron transport; Au; Al_2O_3; MIS (Liu, X. (99) 556)
Schottky diode
Diamond; Gas sensor; Benzene; Toluene (Gurbuz, Y. (99) 207)
Segregation
Crystallite growth inhibition; Free CaO; STEM image; EELS microphotograph (Min, B.-K. (99) 288)
Selective detection
Mercuric ions; SPR; 1,6-Hexanedithiol (Chah, S. (99) 216)
Selectivity coefficients
DB18C6; Membrane electrode; Potentiometric sensor; Calcium ions (Kumar, A. (99) 340)
Selectivity
SnO_2-based sensor; Two-layer thick films; Combustion gas; Alumina-supported Pd catalyst; Stability (Su, P.-G. (99) 304)
Selectivity
Tin oxide; Gas sensor; NASICON; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; VOC (Hetznecker, A. (99) 373)
Self-assembled electrode
Electrochemical sensor; Multi-wall carbon nanotubes; CO; Determination (He, J.-B. (99) 1)
SEM
SnO_2 sensor; RF induction plasma deposition; XRD; High sensitivity (Shi, L. (99) 361)
Semiconductor
Cl_2 sensing; $ZnFe_2O_4$; Microemulsion; Spinel-type oxide (Niu, X. (99) 405)
Sensing temperature
Phthalocyanine; Vacuum deposition; Gas sensor; Film thickness (Lee, Y.-L. (99) 281)
Sensitive film
Explosives detection and quantification; Color chemical reaction (Dorozhkin, L.M. (99) 568)
Sensor
Carbon monoxide; Hydrogen; Fuel cell; Polymer (Planje, W.G. (99) 544)
Sensors
Gases; Fluorine; Polymer electrolyte; V_2O_5 and electrochemical cell (Sathiyamoorthi, R. (99) 336)
Sevoflurane
Fluoromethyl 2,2,2-trifluoro-1-[trifluoromethyl] ethyl ether; Anaesthetic; Oxygen; Nitrous oxide; Reduction; Microelectrode (Floate, S. (99) 236)
Silica sol–gel
Alizarin red S; Aluminum ions; Chemical modified electrode (Di, J. (99) 468)
Silicon oxide
Cantilever; Gas sensor; Hydrofluoric acid (HF); Atomic force microscope (AFM) (Mertens, J. (99) 58)
Smart hydrogel
Hydrogel sensor; Hydrogel application; Phase transition; Quartz crystal microbalance; pH sensor; Poly(vinyl alcohol); Poly(acrylic acid) (Richter, A. (99) 579)
Smart hydrogel
Valve; Microvalve; Operation mode; Phenomena of volume phase transition (Richter, A. (99) 451)
SnO_2 gas sensor
Modulating temperature; Pesticide residue; Gas analysis (Huang, X. (99) 330)
SnO_2 sensor
RF induction plasma deposition; XRD; SEM; High sensitivity (Shi, L. (99) 361)
SnO_2-based sensor
Two-layer thick films; Combustion gas; Alumina-supported Pd catalyst; Selectivity; Stability (Su, P.-G. (99) 304)
Sodium-aluminosilicates
Lithium silicates; Y-stabilized zirconia; Li_2CO_3; Electromotive force; CO_2 gas sensor (Shimamoto, Y. (99) 113)
Sodium-aluminosilicates
Y-stabilised zirconia; Na_2CO_3; CO_2 gas sensor; Electromotive force (Shimamoto, Y. (99) 141)
Soft actuator
Polyaniline; Electrochemomechanical deformation; pH dependence; Temperature dependence; Load effect (Takashima, W. (99) 601)
Soft lithography
Protein micro array; Protein chip; Micro stamp; Surface tension (Lin, S.C. (99) 174)
Sol–gel film
Hemoglobin; Direct chemistry; H_2O_2 biosensor (Wang, Q. (99) 50)
Sol–gel
Piezo-optical sensor; Copper(II); Eriochrome cyanine R (Wright, J.D. (99) 134)
Sol–gel
Tin oxide; Gas sensor; NASICON; Composites; Ionic conductor; Solid electrolyte; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Solid electrolyte
Tin oxide; Gas sensor; NASICON; Composites; Ionic conductor; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Spinel-type oxide
Cl_2 sensing; $ZnFe_2O_4$; Microemulsion; Semiconductor (Niu, X. (99) 405)
SPR sensor
"Allotropized" water; Water; Dielectric function (Muñoz Aguirre, N. (99) 149)
SPR
Mercuric ions; 1,6-Hexanedithiol; Selective detection (Chah, S. (99) 216)
Spray pyrolysis
In_2O_3; Film structure; Gas response; Ozone (Korotcenkov, G. (99) 297)
Stability
SnO_2-based sensor; Two-layer thick films; Combustion gas; Alumina-supported Pd catalyst; Selectivity (Su, P.-G. (99) 304)
STEM image
Crystallite growth inhibition; Free CaO; EELS microphotograph; Segregation (Min, B.-K. (99) 288)
Stern–Volmer equation
1-Pyrenedecanoic acid; Chemisorption layer; Perfluorodecanoic acid; Fluorescence (Fujiwara, Y. (99) 130)
Structural isomer
Identification; Alcohol; Adsorption; Catalytic combustion; Micro gas sensor (Sasahara, T. (99) 532)

Surface plasmon resonance
Biosensor; Optical sensor; Chemical sensor (Alieva, E.V. (99) 90)
Surface polarity controlling method
Odor sensor; Partial structure; Artificial nasal mucus; Constant phase element (Izumi, R. (99) 315)
Surface modification
Electrochemical polymerization; Conducting polymer; Poly(3,4-ethylenedioxythiophene) derivatives; Neural probes (Xiao, Y. (99) 437)
Surface plasmon resonance (SPR)
Label-free imaging; Biomolecular interactions (Li, P.Y. (99) 6)
Surface tension
Protein micro array; Protein chip; Soft lithography; Micro stamp (Lin, S.C. (99) 174)

Temperature dependence
Polyaniline; Electrochemomechanical deformation; Soft actuator; pH dependence; Load effect (Takashima, W. (99) 601)
Thermal sensing resistor
Oxygen sensor; Oxygen–hydrogen reaction; Catalysis (Tan, F. (99) 14)
Thermodynamic
Hydrogen sensors; AlGaAs Schottky diode; Response time (Cheng, C.-C. (99) 425)
Thick film sensor
Nanophase tin dioxide; Pore structure; Crystallinity; Bimodal distribution (Ahn, J.-P. (99) 18)
Thick film
Tin oxide; Gas sensor; NASICON; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Selectivity; VOC (Hetznecker, A. (99) 373)
Time-of-flight
Flow sensor; Electrophoresis; Protein (Sengupta, S. (99) 25)
Tin dioxide
Ethanol detection; Gas sensing; High sensitivity; Dopants and platinum (Ivanov, P. (99) 201)
Tin oxide
Gas sensor; NASICON; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; Selectivity; VOC (Hetznecker, A. (99) 373)
Toluene
Diamond; Gas sensor; Benzene; Schottky diode (Gurbuz, Y. (99) 207)
Transferrin
Fluoroimmunosensing; Prochlorperazine (Li, Z.-Z. (99) 562)
TSM quartz resonators
Impedance analysis; BVD equivalent circuit; Viscoelastic properties; Adsorption; Organic vapours (Holloway, A.F. (99) 355)
Two sensors circuit
Resistance sensors; Ratio of output signals (Hu, X. (99) 310)
Two-layer thick films
SnO_2-based sensor; Combustion gas; Alumina-supported Pd catalyst; Selectivity; Stability (Su, P.-G. (99) 304)

V_2O_5 and electrochemical cell
Sensors; Gases; Fluorine; Polymer electrolyte (Sathiyamoorthi, R. (99) 336)
Vacuum deposition
Nickel phthalocyanine; Gas sensor; Morphology (Liu, C.J. (99) 344)
Vacuum deposition
Phthalocyanine; Gas sensor; Film thickness; Sensing temperature (Lee, Y.-L. (99) 281)
Valve
Ferrofluid; Pump; Microfluidic; Lab-on-a-chip (Hartshorne, H. (99) 592)
Valve
Smart hydrogel; Microvalve; Operation mode; Phenomena of volume phase transition (Richter, A. (99) 451)
Vancomycin
Enantioselective; Potentiometric membrane electrode; Macrocyclic antibiotics; D-Pipecolic acid (Rat'ko, A.A. (99) 539)
Variable selection
Genetic algorithm; Fuzzy ARTMAP; Gas sensor array (Llobet, E. (99) 267)
Viscoelastic properties
TSM quartz resonators; Impedance analysis; BVD equivalent circuit; Adsorption; Organic vapours (Holloway, A.F. (99) 355)
VOC
Tin oxide; Gas sensor; NASICON; Composites; Ionic conductor; Solid electrolyte; Sol–gel; Thick film; Selectivity (Hetznecker, A. (99) 373)
VSCs
Halitosis; QCM; Preconcentrator; Odor sensing system (Ito, J. (99) 431)

Water resistance property
Lanthanum ferrite; Composite material; Humidity sensor; Humidity sensing property (Wang, J. (99) 586)
Water
SPR sensor; "Allotropized" water; Dielectric function (Muñoz Aguirre, N. (99) 149)

XRD
SnO_2 sensor; RF induction plasma deposition; SEM; High sensitivity (Shi, L. (99) 361)

Y-stabilised zirconia
Sodium-aluminosilicates; Na_2CO_3; CO_2 gas sensor; Electromotive force (Shimamoto, Y. (99) 141)
Y-stabilized zirconia
Sodium-aluminosilicates; Lithium silicates; Li_2CO_3; Electromotive force; CO_2 gas sensor (Shimamoto, Y. (99) 113)

Zinc
Fluorescent sensor; Ratiometric; Bis(pyrrol-2-yl-methyleneamine) (Wu, Z. (99) 511)
Zirconia
Gas sensors; Amperometric sensor; Multi-electrode cell; Propene (Schmidt-Zhang, P. (99) 258)
Zirconia
Oxygen sensor; Electrode dynamics; Platinum electrode (Wang, D.Y. (99) 571)
$ZnFe_2O_4$
Cl_2 sensing; Microemulsion; Semiconductor; Spinel-type oxide (Niu, X. (99) 405)